EXHIBIT A

August 30, 2004

Country	Filed	Serial #	Issued	Patent #	Status				
VISIBLE SPECTRUM MODULATOR ARRAYS									
EPC JAPAN UNITED STATES WIPO UNITED STATES	05/01/1995 05/01/1995 05/05/1994 05/01/1995 04/23/1986 03/04/1988 01/12/1989 03/05/1990 11/18/1991 05/01/1993 02/25/2002	95918880.6 7-529030 08/238,750 PCT/US95/0535 06/855,166 07/166,744 07/296,896 07/489,794 07/794,819 08/032,711 10/082,397	11/10/1 398 8	5,835,255	NAT PHASE NAT PHASE ISSUED ABANDONED ABANDONED ABANDONED ABANDONED ABANDONED ABANDONED ABANDONED ABANDONED PENDING				
INTERFEROMETRIC MODULATION									
JAPAN 11/06/1996 UNITED STATES UNITED STATES UNITED STATES	09-518276 07/31/1996 01/27/1999 11/16/1995	08/688,710 09/238,340 08/554,630	03/21/2000 04/25/2000	6,040,937 6,055,090	PENDING ISSUED ISSUED ABANDONED				
INTERFEROMETRIC MODULATION OF RADIATION									
UNITED STATES	12/19/1996 10/10/2001 11/21/2001 02/19/2002 04/07/1999 01/05/2004	08/769,947 09/974,544 09/991,378 10/078,282 09/966,843 NOT ASSIGNE	01/20/2004 ED	6,680,792	ABANDONED ISSUED PENDING PENDING ALLOWED PENDING				
VISIBLE SPECTRUM MODULATOR ARRAYS									
UNITED STATES UNITED STATES	11/05/1996 08/20/1999	08/744,253 09/378,143	11/05/ ⁻ 996	5,986,796	ISSUED ABANDONED				
INTERFEROMETRIC	MODULATION (<u>OF RADIATION</u>							
SOUTH KOREA TAIWAN TAIWAN UNITED STATES WIPO	10/09/1999 04/07/1999 04/07/1999 04/08/1998 04/01/1999	2000-7011227 88105551 89113021 09/056,975 US99/07271	TW16.i294 6,674,:i62	10/02/2002 01/06/2004	NAT PHASE ABANDONED ISSUED ISSUED PENDING				
PHOTONIC MEMS AND STRUCTURES									
UNITED STATES WIPO UNITED STATES UNITED STATES	10/05/1999 07/10/2001 11/13/2001 08/19/2002	09/413,222 US01/41341 10/012,092 10/224,029	6,650,455		PENDING PENDING ISSUED PENDING				
Gray Cary\GT\6398300.3 683142-136695	•	3							

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TAIWAN JAPAN SOUTH KOREA	3/22/2002 07/10/2001 07/10/2002	91105559 2003-512759 2004-700433		ı	PENDING PENDING PENDING				
DIRECTLY LAMINATED TOUCH SENSITIVE SCREEN									
UNITED STATES	06/05/2001	09/875,401	•		PENDING (
HERMETIC SEAL AND METHOD TO CREATE SAME									
UNITED STATES	08/01/2001	09/921,196	6,589,625	07/08/2003	ISSUED				
CONTROLLING MICRO-ELECTROMECHANICAL CAVITIES									
UNITED STATES	02/12/2002	10/076,224	6,710,938	03/23/2004	ISSUED				
A METHOD FOR FABRICATING A STRUCTURE FOR MICROEI ECTROMECHANICAL SYSTEMS (MEMS) DEVICE									
UNITED STATES WIPO	02/12/2002 04/29/2002	10/074,562 US02/13442			ALLOWED PENDING				
MICROELECTRICMECHANICAL SYSTEMS DEVICE AND MET HOD FOR FABRICATING SAME									
UNITED STATES WIPO	02/27/2002 04/29/2002	10/084,893 US02/13462	6,574,033	06/03/2003	ISSUED PENDING				
A DEVICE HAVING A LIGHT-ABSORBING MASK AND A MET HOD FOR FABRICATING SAME									
UNITED STATES WIPO	07/02/2002 06/27/2003	10/190,400 US03/20433	6,741, £ <i>7</i> 7	05/25/2004	ISSUED PENDING				
CONTROLLING ELECTROMECHANICAL BEHAVIOR OF STRUCTURES WITHIN A MICROELECTROMECHANICAL SYSTEMS DEVICE									
UNITED STATES WIPO TAJWAN	09/18/2003 09/20/2002 09/18/2003	10/251,196 US03/30016 92125860			PENDING PENDING PENDING				
A METHOD FOR MANUFACTURING AN ARRAY OF INTERFE COMETRIC MODULATORS									
UNITED STATES	04/15/2003	10/414,594	•		PENDING				
THIN FILM PRECURSOR STACK FOR MEMS MANUFACTURING									
UNITED STATES	06/24/2003	10/606,001			PENDING				
SEPARABLE MODULATOR									
UNITED STATES	08/19/2003	10/644,312		•	PENDING				
AREA ARRAY MODULATION AND LEAD REDUCTION IN IN ERFEROMETRIC MODULATOR ARRAYS									
UNITED STATES	12/09/2003				PENDING				
METHOD TO CHANGE TEMPORAL RESPONSE OF IMODS									

UNITED STATES 03/03/2004 PENDING

IMOD WITH INTEGRATED SHUNT RESISTOR NETWORK

UNITED STATES 02/03/2004 PENDING

INTEGRAL MODULATOR ILLUMINATION

UNITED STATES 03/04/2004 PENDING

MEMS DEVICES WITH UNRELEASED THIN FILM COMPONEN IS

UNITED STATES 11/03/2003 PENDING